

Docket No.: 1293.1126

## HE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kyung-geun LEE et al.

Serial No. 09/603,204

Confirmation No. 2962

Filed: June 26, 2000

Examiner: Gautam Patel

APPARATUS AND METHOD OF COMPENSATING FOR TILT AND/OR DEFOCUS OF For:

A DISC DURING RECORDING

AMENDMENT FILED APRIL 30, 2003 AND REQUEST FOR EXAMINER INTERVIEW **RECEIVED** 

Group Art Unit: 2655

Assistant Commissioner for Patents Washington, D.C. 20231

JUN 1 7 2003

Sir:

Technology Center 2600

This is responsive to the Final Office Action mailed February 12, 2003, having a shortened period for response set to expire on May 12, 2003.

The following amendment and remarks are respectfully submitted.

In addition to the amendment and remarks below, Applicants respectfully request an interview with the Examiner at the Examiner's earliest convenience to expedite the prosecution of the instant application. It is believed that an interview will better resolve any remaining issues than words alone. Accordingly, the Examiner is encouraged to contact the undersigned to set up an interview at a time that is convenient to the Examiner.

## IN THE CLAIMS:

Please CANCEL claim 10 without prejudice or disclaimer, and AMEND claims 9, 11, 13, 16, 17, 51, 53, 56, and 62, as follows:

(TWICE AMENDED) A method for compensating for defocus of an optical recording medium, the method comprising:

detecting the defocus of the optical recording medium using a light beam having a wavelength of roughly 430 nm or less; and

compensating a recording signal with respect to the detected defocus, including adjusting a power level required for recording the recording signal.